

RECEIVED  
CENTRAL FAX CENTER  
AUG 24 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/743,985

Confirmation No.: 9060

In re application of: Shui-Ming Cheng et al.

Filed: December 22, 2003

Technology Center/Art Unit: 2813

Examiner: Laura M. Schillinger

Docket No.: N1085-00168 (2003-0219)

Customer No.: 08933

Title: BODY CONTACT FORMATION IN  
PARTIALLY DEPLETED SILICON ON  
INSULATOR DEVICE

I CERTIFY THAT THIS CORRESPONDENCE COMPRISED OF EIGHT  
(8) PAGES IS BEING TRANSMITTED BY FACSIMILE TO THE PATENT  
AND TRADEMARK OFFICE ON THE DATE AND TO THE FACSIMILE  
NUMBER SHOWN BELOW

ON: August 24, 2005

FACSIMILE NO. 571.273.8300

Steven E. Kopp  
SIGNATURE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

Responsive to the Office Action dated March 1, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.